REPORT DO	CUMENTATION	N PAGE	AFRL-SR-I	BL-TR-01-	
Public reporting burden for this collection of information is edata needed, and completing and reviewing this collection this burden to Department of Defense, Washington Headqu 4302. Respondents should be aware that not	of information. Send comments regar parters Services, Directorate for Infor- any other provision of law, no person	rding this burden estimate or any ration Operations and Reports (0 shall be subject to any penalty fo	013	•	ning the educing 2202- currently
1. REPORT DATE (DD-MM-YYYY)	2. REPORT TYPE			ATES COVERED (From - To)	
10/01/01	Final Progress	Report		15/99 - 12/31/99	
4. TITLE AND SUBTITLE			5a. (	CONTRACT NUMBER	
Femtosecond Laser system f	or Multi-channel	multicolor			1
two-photon technology.					i
			5b. 0	GRANT NUMBER	
				OSR F 49620-99-1-0316	5
			50 1	PROGRAM ELEMENT NUMBER	
			00.1	NOOTONII EEEMENT NOMBER	
e AUTHOR(S)			5d 1	PROJECT NUMBER	
6. AUTHOR(S) Dr. Paras N. Prasad		J 54. 1	RODEOT ROMBER		
Dr. Paras N. Prasau			5e. TASK NUMBER		
			J 56.	ASK NOWDER	
		- F6 33	VODE LINE NUMBER		
			51. V	VORK UNIT NUMBER	
7. PERFORMING ORGANIZATION NAME(	S) AND ADDRESS(ES)			ERFORMING ORGANIZATION R UMBER	EPORT
	.,		l N	UMBER	
Research Foundation of SUN	Υ,		İ		
PO Box-9,			i		
Albany, NY-12201-0009.					
9. SPONSORING / MONITORING AGENC	/ NAME(S) AND ADDRESS	S(ES)	10.3	SPONSOR/MONITOR'S ACRON	/M(S)
AFOSR/NL					
DANTE DEL	T 1000M 73	2			
801 N. RANDOLPH ST, ROOM 732			11.	SPONSOR/MONITOR'S REPORT	۲
101100 TOA) UA 17702-1977				NUMBER(S)	
				FICE OF SCIENTIFIC RESEARCH (AFOST	ለ)
12. DISTRIBUTION / AVAILABILITY STAT	EMENT 0	^	- AIR FORGE OF	THE OF SULETIME THE TECHNICAL REL	PORT
12. DISTRIBUTION / AVAILABILITY STAT	ric Release	: Nistribu	TIONOFICE OF IT	VIEWED AND IS APPROVED FOR PUBLIC	RELEASE
13. SUPPLEMENTARY NOTES			I AM ACD 100	-12. DISTRIBUTION IS UNLIMITED.	
PALMED 120.17 DIGHTS					
				·	
14. ABSTRACT					
We have acquired the femtosec	ond laser system Tsu	ınami from Spectra	a Physics, CA	A, (\$89,900) pumped by	a DPSS
laser Millennia(\$54,500), also	from Spectra Phys	sics. CA, and used	them for d	eveloping multi-photon	process
based technologies. It is know	m that two photon 6	voitation produce	s highly loca	lized effect near the foc	al noint
based technologies. It is know	ii iiiai two-photon c	xcitation produce.	s inginy loca	11 4 1 4 1 4 1 4 1 4 1 4 1 4 1 4 1 4 1	ar point
when the pump beam is focused					
a highly localized two-photon	initiated process at	different depths, v	with a very	well defined depth contr	ol. This
feature provides an unique opportunity to develop such diverse applications as for 3D volume imaging, 3D optical circuitry fabrication, high density 3D optical data storage, etc. In this context we were using the newly acquired					
circultry labrication, high dens	ity 3D optical data s	storage, etc. in u	ns comext w	e were using the newly a	acquired
laser system (Ultra-short pulse,	high repetition rate	Ti:Sapphire laser	r, Tsunamı p	umped by a diode pump	ied solid
state laser, Millenia) for two-ph	oton confocal micro	scopy and spectro	scopy, two-p	photon initiated micro-fab	orication
and two-photon optical datas	torage. We were	able to use this t	new laser sy	stem with our confocal	micro-
spectroflourimeter as well as for	fobrigating 2D anti-	nol oironitmy			
spectronourimeter as well as for	raoricating 3D option	car circulary.			
15. SUBJECT TERMS					
16. SECURITY CLASSIFICATION OF:		17. LIMITATION OF ABSTRACT	18. NUMBER OF PAGES	19a. NAME OF RESPONSIBLE	PERSON
- DEDORT   h ADSTRACT	c. THIS PAGE		,	19b. TELEPHONE NUMBER (in	nclude area
a. REPORT b. ABSTRACT	Λ -		10	code)	roraue area
(Inclas) (Inclas	Unclas		L CE		

## Instruments acquired and Justification:

We have acquired a tunable femto-second Ti:Sapphire laser, Tsunami from Spectra-Physics, CA(\$89,900) pumped by a diode pumped solid state Laser Millennia from Spectra-Physics, CA(\$54,500). The acquired laser can produce high repetition rate femto-second pulses which can be used for the study of multi-photon processes. This laser with its tunability and ultra short pulses, was ideal for our work on multi-photon microscopy, mutli-photon process based 3D microfabrication of optical channel circuitry as well as the two-photon process based 3D optical data-storage.

## Summary of Research Projects for which the equipment was used:

Two-photon excitation produces highly localized effect near the focal point when the pump beam is focussed by a lens. This property can be used to achieve excellent depth resolution to create a highly localized two-photon initiated process at different depths, with a very well defined depth control. We therefore have well defined volume access by optical sectioning of a medium. This feature provides an unique opportunity to develop such diverse applications as for 3D volume imaging, 3D optical circuitry fabrication, high density 3D optical data storage, etc. In this context we were using the newly acquired laser system (Ultra-short pulse, high repetition rate Ti:Sapphire laser, Tsunami pumped by a diode pumped solid state laser, Millenia) for two-photon confocal microscopy and spectroscopy, two-photon initiated micro-fabrication and two-photon optical datastorage,. Some examples are given here.

## 3D micro-fabrication:

A novel approach was used for micro-fabrication of three-dimensional optical circuitry using in-situ two-photon assisted polymerization in an as-formed bulk sample. The bulk media consisted of a blend of photo-curable and thermally curable epoxies. 1x2 and 1X4 splitters were fabricated inside the volume and imaged by confocal microscopy. End-fire coupling of a He-Ne laser beam into these splitters was also achieved. By controlling the size and shape of the waveguides, we were able to make single mode or multimode waveguides.

For our studies we used a mixture of UV curable epoxy NOA 72( from Norland Optical Norland Products Inc., New Jersey, USA.) and Epo-tek301( from Epoxy

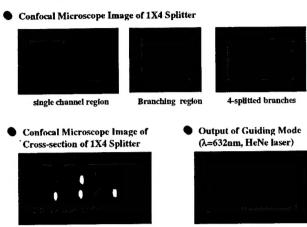
Technology, Inc. Massachusetts, USA) and a two-photon chromophore AF183 (6-benzothiazol-2-yl(2-naphtyl))diphenylamine synthesized at Airforce Research Laboratory). The mixture of UV curable epoxy, thermal epoxy and the chromophore was spread over a glass slide and after curing for 24 hours at room temperature formed a thick film of thickness around 100-150  $\mu$ m.

For the fabricating of waveguide channels in the bulk, we used 800 nm, ~100 fs pulses from a Ti:Sapphire laser (Tsunami from Spectra Physics). The average power of the laser was ~ 1W. After attenuators and beam expansion, the average power incident over the sample was reduced to 40mW. The details of the setup used for the fabrication was similar to that was reported earlier. We have used 60X oil immersion objective (NA 1.4, from Nikon) for focusing the laser beam on to the sample, after expanding the laser beam to utilize the full NA of the objective. The written channels were found to be asymmetric along YZ plane (elongated along Z direction), even though the usage of high NA objective reduced the asymmetry. To achieve a symmetrical channel we have written the channels 3-5 times by slightly translating the sample in X or Y direction. This way we were able to fabricate comparatively symmetric channels.

The fabricated channel waveguide's geometry and location were monitored using fluorescence confocal microscopy. After the two-photon induced photoprocess, the dye AF183 show a shift in the excitation and fluorescence properties and this can be utilized to image the written channels using confocal laser scanning microscope (MRC1024 from Bio-Rad). The confocal microscopy images presented in this paper are acquired using an excitation of 488nm line from a Kr:Argon laser.

The advantage of this rapid laser prototyping technique is the easiness of crating 3-dimensional waveguides and other optical circuit creation. To demonstrate this we have written series of vertically stacked channels. The confocal images as well as the nearfiled images of the coupled laserlight from the channel waveguides are shown in the figure below (fig.1).

Fig 1



In conclusion, we have used two-photon absorption based laser rapid prototyping to fabricate single mode and multimode channel waveguides as well as 1x4 beam splitters inside a pre-gelled bulk. We have also verified the mode structure of these channel waveguides by coupling laser into these channels and observing the output modes.

## Confocal Localized spectrometer:

for a single mode channel waveguide

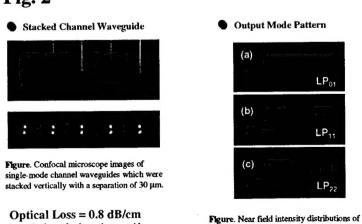
(by cut-back method)

We have developed our own system of Two-photon Laser Scanning Micro-spectrofluorometer (TPLSMF) for the purpose of multi-color spectral imaging. With one-photon or two-photon confocal laser scanning microscopy, images are acquired through broad band emission filters, which cannot distinguish between small changes in

guided modes at \u2213=632nm. (a) single mode

and (b), (c) multi mode channel waveguides.

Fig. 2



the spectral profiles of the sample. To get a complete picture of the sample, their emission spectra also have to be monitored. In order to acquire the spectral images, we have developed a confocal/Multiphoton localized spectrometer, which has the spatial resolution comparable to the confocal/Multiphoton microscope as well as a spectral resolution of ~1nm. TPLSM, TPLSMF has inherent localization ability and much less photodamage compared with one-photon system. Because excitation is limited to the focus point, TPLSMF can provide spectral resolution of the diffraction-limited spot size without any pinhole. This feature makes it very promising in studying the dynamic changes inside the living cells. In contrast, in one-photon confocal microspectrofluorometry, researchers have to reduce the aperture to get localized spectra, which is in fact a tradeoff between signal levels and spatial resolution. Therefore, it is hard to reach the theoretical spatial resolution of using one-photon confocal microspectrofluorometer.

Spectrograph consists of a fiber (1 mm, multi-mode) coupled monochromator (Holoscope from Keiser Inc.), equipped with a cooled CCD (Princeton Instruments) as detector. The Setup for Two-photon Laser Scanning Microspectrofluorometry (TPLSMF) is shown as Figure 3.

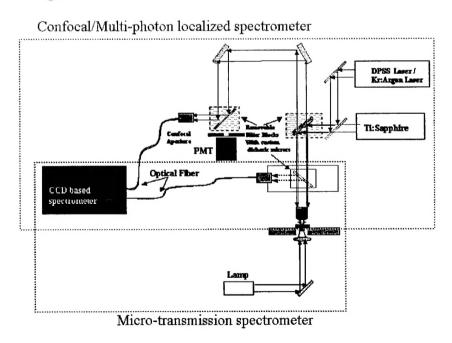


Fig. 3 Schematic diagram of the confocal/Multiphoton localized spectrometer and micro-transmission spectrometer. This fiber coupled localized spectrometer was built upon the existing confocal microscope

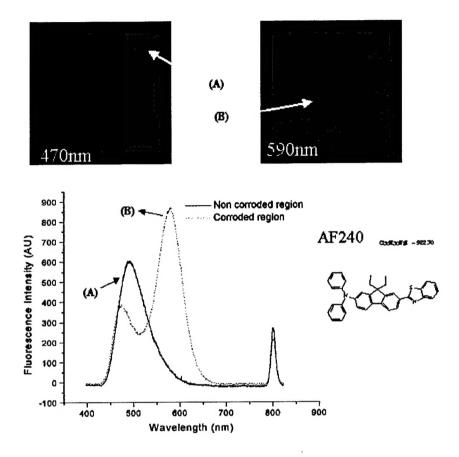


Fig. 4. Polymeric paint coatings doped with tow-photon chromophore AF-240, was made on aluminum substrates jept in acidic environment. Two-Photon confocal spectrally resolved images and localized spectra taken at two different points are shown here. Spectra are taken from aregion of the size  $\sim 10~\mu m$  X  $10\mu m$ .

The fluorescence acquired under the microscope was directed to a fiber by a dichoric mirror without passing any filters inside the scanhead. An absorption filter in the IR range was used inside the spectrograph to cut off the excitation lines from laser.

Fig. 4 shows an image and spectra taken using this versatile confocal microscope and localized spectrometer o a polymeric paint film ( at a depth of  $\sim 50~\mu m$  from surface, i.e,  $\sim 2$  times the MFP of the paint film.). The change in fluorescence as well as the spectrally resolved imaging clearly shows the penetration of acidic environment into the film. This is a potential tool to detect the onset of corrosion due to acidic or other environmental changes.

Our study demonstrates that confocal microscopy can be used as a tool for nondestructive evaluation of multilayer coatings and inspections of any corrosion on the underlying surface without removing or peeling off the paint layer. We were able to non-destructively study the onset of damages in paint coatings using confocal microscopy( two-photon fluorescence and reflection mode).

So with a combination of confocal/Multiphoton gated imaging, and the study of the change in spectral profile using a confocal/Multiphoton localized spectrometer, one can study the effect of change in environmental conditions on a pigmented polymeric paint coating, or the onset of corrosion of a metallic substrate through the coating.